

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/781,574	HUJANEN ET AL.	
Examiner		Art Unit		Page 1 of 1
Kevin M. Bernatz		1773		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,270,572	08-2001	Kim et al.	117/93
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Klaus, J., Ferro, S., George, S., J. Elec. Soc., 147(3), 1175-1181, 2000 (Titled: "Atomic Layer Deposition of Tungsten Nitride Films Using Sequential Surface Reactions")
	V	Provisional Application 60/284,624
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.